



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Manabu NAKAMURA et al.**

Art Unit: **2894**

Application Number: **10/659,748**

Examiner: **Bradley Smith**

Filed: **September 11, 2003**

Confirmation Number: **3468**

For: **METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE HAVING
GATE OR TUNNEL INSULATION FILM**

Attorney Docket Number: **031140**
Customer Number: **38834**

AMENDMENT UNDER 37 C.F.R. § 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

February 17, 2009

Sir:

In response to the Office Action dated November 28, 2008, Applicants amend the claims as follows and submit the following remarks.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 6 of this paper.